

TATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

New York, New York

Sadao HIRAE et al.

Date:

2003 January 1

P/1596-51

Serial No.:

09/751,000

Group Art Unit: 2812

Filed:

December 29, 2000

Examiner:

Gentle E.

For:

SUBSTRATE TREATING METHOD AND APPARATUS

Asst. Commissioner for Patents Washington, D.C. 20231

AMENDMENT/SUBMISSION

This is a response to the Office Action mailed September 16, 2002 in the above-identified application. Reconsideration of the application is respectfully requested.

FEE CALCULATION Any additional fee required has been calculated as follows:											ひりつ
	If checked, "Small Entity" status is claimed. NO. CLAIMS HIGHEST NO.							CHNOLOGY CENTER 1	2003	EINFU	
		FTER NDMEN		PREVIOUSI PAID FOR		EXTRA PRESE	ENT	RATE	700	ADDIT. FEE	
TOTAL		7	MINUS		* =		X	(\$9 SE or \$18)	\$0		_
INDEP.		4	MINUS	5	** =	0	X	(\$42 SE or \$84)	\$0		_
FIRST I	PRESE	NTATIO	ON OF M	ULTIPLE DE	PENDE	ENT CLAIM	X	(\$140 SE or \$280)	\$0		
* not les	ss than	20 ** no	ot less tha	n 3				TOTA	L \$ =		=

If any additional payment is required, a check which includes the calculated fee of \$\sume9\$ (OFGS Check No.) is attached.

In the event the actual fee is greater than the payment submitted or is inadvertently not enclosed or if any additional fee during the prosecution of this application is not paid, the Patent Office is authorized to charge the underpayment to Deposit Account No. 15-0700.

BEST AVAILABLE COPY